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PATENT APPLICATION

# 72813  
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JUN 28 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
KIYOFUMI SAKAGUCHI, ET AL. ) Examiner: Not Yet Assigned  
 ) Group Art Unit: 2813  
Application No.: 10/085,046 )  
Filed: March 1, 2002 )  
For: PROCESS FOR )  
PRODUCTION OF )  
SEMICONDUCTOR )  
SUBSTRATE ) June 26, 2002

Commissioner for Patents  
Washington, D.C. 20231

SECOND PRELIMINARY AMENDMENT

Sir:

Prior to action on the merits, please further amend the above-identified application as follows:

IN THE SPECIFICATION:

Please amend paragraph [0001] to read as follows. A marked-up copy of the paragraph showing the changes made can be found in the attached appendix:

This application is a continuation-in-part of application number 09/161,775 filed September 29, 1998, pending, which was a division of application 08/863,717 filed May 27, 1997, now U.S. Patent 5,856,229, which was a continuation of application number